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PATENT

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Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 16, 2005

William B. Allen Beg. No. 48 389

Date

Applicants:

Toshiharu Furukawa et al.

Serial No.:

10/732,951

Filed:

December 11, 2003

Art Unit:

2826

Examiner:

Evan T. Pert

Confirmation No.:

9265

Title:

SELECTIVE SYNTHESIS OF SEMICONDUCTING

CARBON NANOTUBES

Atty Docket No.:

IBM-270

Cincinnati, Ohio 45202

September 16, 2005

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of candor and good faith imposed by 37 C.F.R. §1.56 and means of complying therewith according to 37 C.F.R. §§1.97 and 1.98, the references listed on the attached Form PTO-1449 are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application.

Subject to the Office's waiver of providing copies of U.S. patents and published applications for applications filed after June 30, 2003, only foreign references and articles are provided, since this application was filed on December 11, 2003, and therefore, subsequent to June 30, 2003.

The Examiner is urged to consider all of the cited documents and to make an independent evaluation of the teachings and materiality of each.

Applicants believe that this communication is being mailed before a first action on the merits and, therefore, no fee is due. If this is not the case, the Commissioner is authorized to charge deposit account 23-3000 for any required fees.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

William R. Allen

Reg. No. 48,389

2700 Carew Tower 441 Vine Street Cincinnati, OH 45202 (513) 241-2324

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	A.L	WO 2004/O40668							rch 14, 2004	F	РСТ	H01L 51/20				Abstract Only
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	A.R	Furukawa et al., United States Patent Application Publication No. US 2005/O167740, Publication Date: August 4, 2005														
	A.S	Fui	Furukawa et al., United States Patent Application Publication No. US 2005/O179029, Publication Date: August 18, 2005													
-	A.T	Fu	uka	wa	et a	l., <u>U</u>	nite	d Sta	tes Patent App	licatio	on Publication No.	US 200	<u>5/O167655,</u>	Publication	n Date:	August 4, 2005
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	C.R	Choi	Choi et al., United States Patent Application Publication No. US 2002/O001905, Choi et al.													
	C.S	Geor	Georg S. Duesberg et al., <u>Large-Scale Integration of Carbon Nanotubes into Silicon Based Microelectronics</u> , Proceedings of SPIE Vol. 5118 (2003), pgs. 125-137													
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